C. Model Construction and Evaluation

- stepwise regression algorithm with Akaika information criterion (AIC)
- **P** be the set of indices of the factors selected from factor screening
- |P' | to denote the number of elements contained in P
- *P* is an arbitrary subset of **P**
- F^p denotes the set of the factors whose indices are contained in P.
- x^p that is a matrix of $N \times (|P|+1)$ $\hat{l}^p = l(\widehat{\beta}(\mathcal{P}), \widehat{\sigma}^2(\mathcal{P}), \widehat{\rho}^2(\mathcal{P})| \mathbf{y}, \mathbf{x}(\mathcal{P}))$

 $l^{\mathcal{P}}(\boldsymbol{\beta}(\mathcal{P}), \sigma_{\boldsymbol{\zeta}}^{2}(\mathcal{P}), \rho^{2}(\mathcal{P}) | \mathbf{x}^{\mathcal{P}}, \mathbf{y})$

C. Model Construction and Evaluation (cont'd)

$$AIC_{SPBM}^{\mathcal{P}} = -2\hat{l}^{\mathcal{P}} + 2\left(1 + \sum_{p \in \mathcal{P}} d_p\right), \qquad (27)$$

- d_p is the increment of degree of freedom
- $d_p = 1$, if F^p is a numerical factor.
- $d_p = -1$, if F^p is a nominal factor.

C. Model Construction and Evaluation (cont'd)

The proposed algorithm for SBPM with variable selection based on **P'** consists of the following steps:

Step 1. Set t = 0 and $\mathcal{P}^0 = \phi$, where ϕ denotes the empty set. Step 2. Calculate $M = AIC_{SPBM}^{\mathcal{P}^0}$. Step 3. t = t + 1. Step 4. Find $p^* = \arg \min_{p \in \mathbf{P}' \setminus \mathcal{P}^{t-1}} \operatorname{AIC}_{\operatorname{SPBM}}^{\{\mathcal{P}^{t-1}, p\}}$. Set $\mathcal{P}^t =$ $\{\mathcal{P}^{t-1}, p^*\}.$ Step 5. If $M > AIC_{SPBM}^{\mathcal{P}^{t}}$ or $t = |\mathbf{P}'|$, set $M = AIC_{SPBM}^{\mathcal{P}^{t}}$ and go to Step 3. Step 6. Set $\mathcal{P}^* = \mathcal{P}^{t-1}$, $\widehat{\boldsymbol{\beta}}^* = \widehat{\boldsymbol{\beta}}(\mathcal{P}^{t-1}), \widehat{\sigma}^{2*} = \widehat{\sigma}^2(\mathcal{P}^{t-1}),$ $\widehat{\rho}^{2*} = \widehat{\rho}^2(\mathcal{P}^{t-1})$ and the final model follows. Finally, the fitted model is as follows:

$$\hat{Y}_{kn} = \mathbf{X}_{kn}^{\mathcal{P}^*} \widehat{\boldsymbol{\beta}}^*.$$
(28)

C. Model Construction and Evaluation (cont'd)

(a) between-batch residuals $e_k^b = \sum_{k=1}^L e_{kn}^{\zeta} / N_k$, $k = 1, \ldots, K$ and (b) within-batch residuals $e_{kn}^w = e_{kn}^{\zeta} - e_k^b$, $k = 1, \ldots, K, n = 1, \ldots, N_k$, where $e_{kn}^{\zeta} = Y_{kn} - \hat{Y}_{kn}$.

D. Time Complexity

- (a) key factor extraction by statistical analysis
- (b) model construction and evaluation.
- N observations
- *P* observed factors
- M_T number of trees to be grown in RF

D. Time Complexity (cont'd)

≻ RF

- CART with the number of factor *P* is $O(\sqrt{P}N \log N)$
- RF is $O(M_T \sqrt{P} N \log N)$
- fit a onedimensional linear regression model by least square approach is *O(N)*

D. Time Complexity (cont'd)

- > SBPM
- Number of iterations be κ, the time complexity of SBPM part in (a) will be O(κPN).
- > Calculating
- λp, p = 1, ..., P and sorting them is at most O(P log P) via a quick sorting algorithm.

D. Time Complexity (cont'd)

- > (a) key factor extraction by statistical analysis
- Thus, the time complexity of (a) be expressed by $O(M_T \sqrt{P} N \log N) + \kappa P N + P \log P$
- If M_T and κ are both fixed, it can be replaced by $O(NP \log N \log P)$.
- > (b) model construction and evaluation.
- In (b), suppose that the number of candidate factors selected in (a) is P'
- For the stepwise forward selection algorithm, at most P'(P' + 1)/2
- the time complexity of a SBPM is limited by $O(\kappa P'^2 N)$
- Thus, the time complexity of (b) can be expressed by $O(P'^4N)$ if κ is fixed.

✓ $O(P^4 N \log N)$, that can be reduced to $O(P^2 N \log N)$ if $P' \approx O(\sqrt{P})$.

V. VALIDATION

> 1) Simulation Setting

- Let *Y* denote the response variable
- Effective factor: the factor that effectively affects *Y*.
- Ineffective factor: the factor that is not an effective factor.
- Between-batch noise: denoted by ε_b^k
- Within-batch noise: denoted by ε_{kn}^{w}
- SBPM-based analysis: The analysis based on SBPM
- Product-based analysis: ignores the dependency of the products within batch
- Batch-based analysis: batch level data
- Factor-assumed analysis : with a dummy factor

> Three types of simulations to facilitate the comparison

- a) Numerical factor case
- b) Nominal factor case
- c) Mixed factor case (half-and-half
- > 1000 factors containing 100 interested factors are considered
- In the 100 interested factors, 10 factors are randomly selected and set as the effect factors of effect 1.
- In the remaining 900 factors, 100 factors are randomly selected and set as the effective factors of effect τ, where τ of range 0.1 to 0.3 is a parameter to control the simulation scenario.

• Pure noises are *i.i.d.* generated from a normal distribution with mean 0 and variance σ_w^2 , where σ_w^2 of range 0.2 to 5 is a parameter to ontrol the simulation scenario.

$$Y_{kn} = \beta_0 + \sum_{p=1}^{100} \beta_p X_{pkn} + \sum_{p=101}^{1000} \beta_p X_{pkn} + \varepsilon_{kn}^w,$$

- > Validation of Single Factor Analysis
- The factors with *p*-values less than the significant level *α*, set as 0.05 in this study, will be regarded as effective factors.
- (a) Type I error R_{α}
- (b) screening accuracy R_a

$$R_{\alpha} = \frac{p_s - p_c}{p_t - p_e},$$
$$R_a = \frac{2p_c + p_t - p_e - p_s}{p_t},$$

- total factors with size p_t
- effective factors with size p_e
- selected factors with size p_s
- catching factors with size p_c

$$R_{\alpha} = \frac{p_s - p_c}{p_t - p_e},$$

$$R_a = \frac{2p_c + p_t - p_e - p_s}{p_t},$$



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$$R_a = \frac{2p_c + p_t - p_e - p_s}{p_t},$$



> Type I error

- ' 🗌' SBPM
- ' Δ ' product-based,
- '+' batch-based,
- 'X' factor-assumed analyses
- numerical input case



> Type I error

- ' 🗌' SBPM
- ' Δ ' product-based,
- '+' batch-based,
- 'X' factor-assumed analyses
- nominal input case.

• $\zeta kn = \xi kn + \varepsilon kn$



> Type I error

- ʻ 🗌' SBPM
- ' Δ ' product-based,
- '+' batch-based,
- 'X' factor-assumed analyses
- mixed input case.



Accuracy

- ' 🗌' SBPM
- ' Δ ' product-based,
- '+' batch-based,
- 'X' factor-assumed analyses
- numerical input case



Accuracy

- ʻ 🗌 ' SBPM
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- Accuracy
- ' 🗌' SBPM
- ' Δ ' product-based,
- '+' batch-based,
- 'X' factor-assumed analyses
- mixed input case



- Validation of SBPM-Based Root Cause Detection Framework:
- *RSSE* is a smaller-the-better measure.
- $\beta p = 1$, if *Fp* is an effective factor.
- $\beta p = 0$, if *Fp* is an ineffective factor.

$$R_{SSE} = \sum_{p=1}^{100} \widehat{\beta}_p - \beta_p,$$

➤ Validation

' □' SBPM-based root
cause detection approach
'Δ' stepwise regression
'+' Lasso

'X' LARS

• numerical input case



➤ Validation

' □' SBPM-based root
cause detection approach
'Δ' stepwise regression
'+' Lasso

'X' LARS

nominal input case



➤ Validation

' □' SBPM-based root
cause detection approach
'Δ' stepwise regression
'+' Lasso

'X' LARS

• mixed input case



Empirical Study

- 1) Problem Definition and Data Preparation
- 2) Key Factor Screening:
- 3) Model Construction and Evaluation

- > 1) Problem Definition and Data Preparation
- The response Y was the wafer CP yield,

> 2) Key Factor Screening:



• 3) Model Construction and Evaluation

$$\begin{split} \hat{Y}_{kn} &= \beta_0 + \beta_1 S667 \mathrm{chrep}_{kn} + \beta_2 S284 \mathrm{chid}_{kn} \\ &+ \beta_3 S1230 \mathrm{chid}_{kn} + \beta_4 S1106 \mathrm{chrep}_{kn} \\ &+ \beta_5 WAT872_{kn} + \beta_6 WAT1067_{kn} \\ &+ \beta_7 WAT99_{kn} + \beta_8 WAT1529_{kn}, \end{split}$$



• 3) Model Construction and Evaluation



Fig. 21. Residuals. Left: between-lot residuals. Right: within-lot residuals. The colors of points are used to distinguish from lots.

• 3) Model Construction and Evaluation



Fig. 22. Within-lot residuals diagnosis. Left: quintile–quentile plot of residuals of within-lot residuals. Right: expected values of response to residuals of within-lot residuals.

• 3) Model Construction and Evaluation



Fig. 23. Box plot and trend chart of S667chrcp.

• 3) Model Cons

Scattering plot of WAT99



Fig. 24. Scattering plot of WAT99.

VI. CONCLUDING REMARKS

- This study proposed an effective framework to detect the root causes for sub-batch processing system for semiconductor manufacturing
- future study can be done to develop robust hypothesis testing when the sample size is small in the early stage of ramping advanced technology nodes.